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# GaInP/GaAs/Si Triple-Junction Solar Cell Formed by Wafer Bonding

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# Outline

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- Triple-junction solar cells
- The GaInP/GaAs/Si solar cell
  - Why these semiconductors?
  - Challenge of the fabrication process
  - Wafer bonding process
- Results of the GaInP/GaAs/Si solar cell characterisation

# Triple-Junction Solar Cells Concentrator Technology

Single-junction Si solar cell:

$$\eta = 25.5 \%$$

Spectrum: AM 1.5g [1]

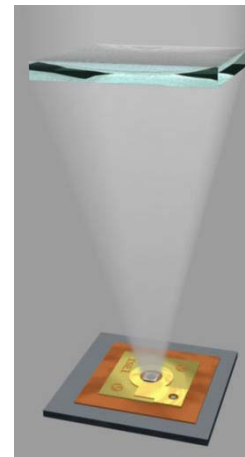
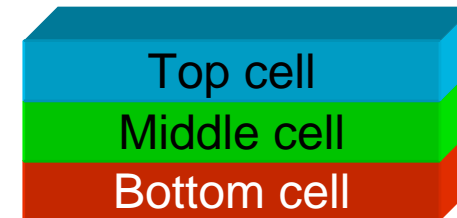
GaInP/GaInAs/Ge triple-junction solar cell:

$$\eta = 41.6 \%$$
 at 364 suns

Spectrum: AM 1.5d [1]

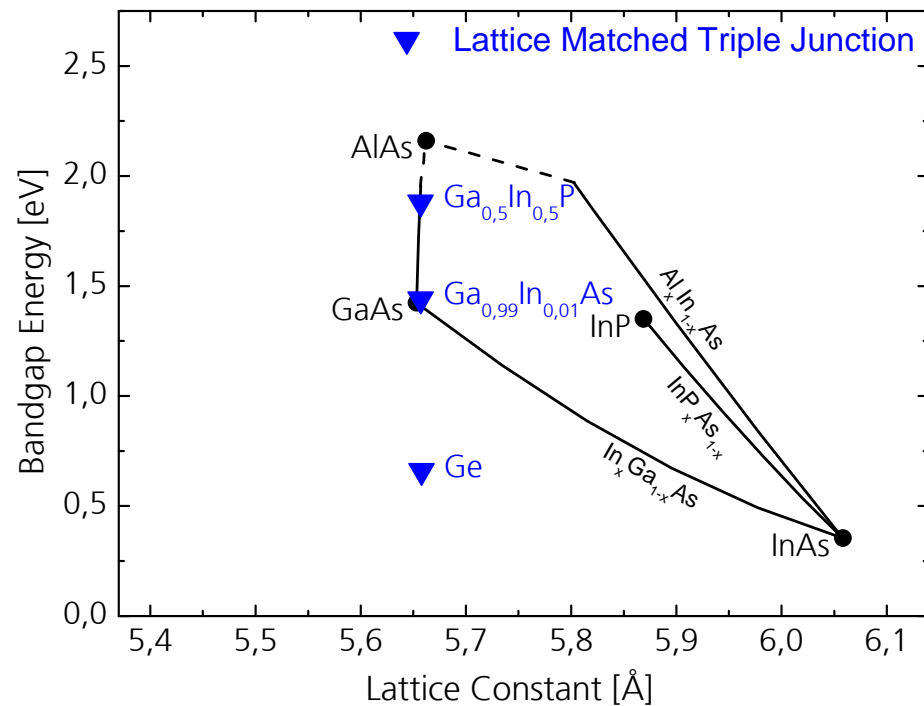
Advantages of concentrator cells:

- Efficiency enhancement under concentrated light
- Cost reduction by decreasing solar cell size to a few mm<sup>2</sup>



# Triple-Junction Solar Cells

## III-V Semiconductors

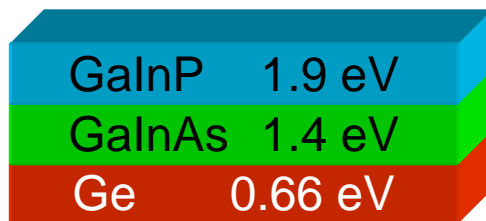


- Wide range of possible bandgap energies
- Epitaxy: high crystal quality for lattice matched semiconductors

# Triple-Junction Solar Cells

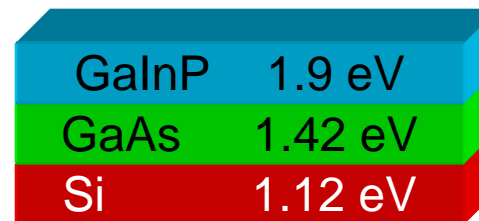
## Solar Cell Designs

### Conventional lattice matched triple-junction solar cell



- Ge bottom cell produces high excess current
  - Cannot be used due to serial connection

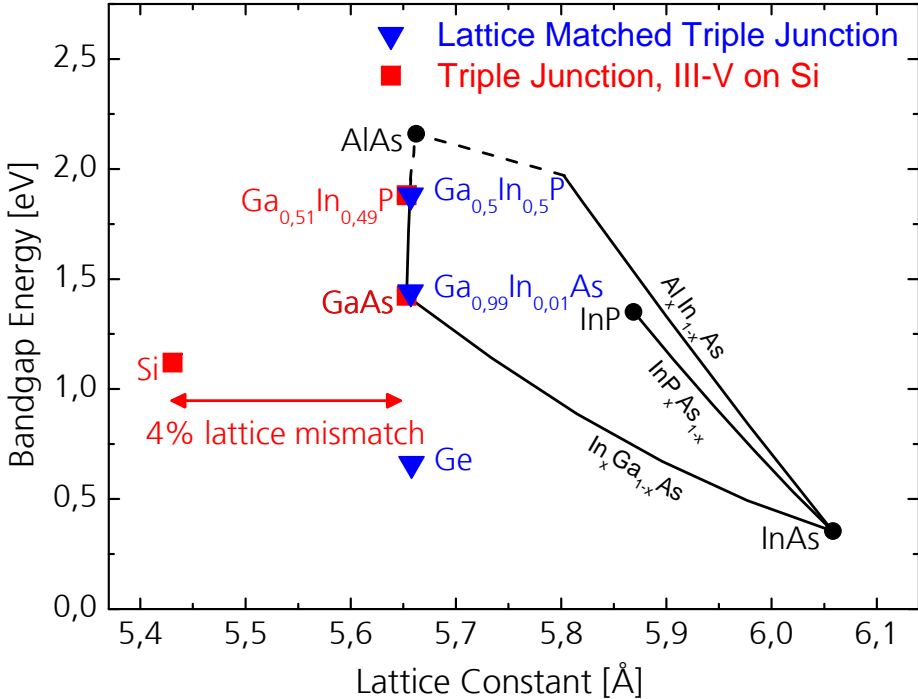
### III-V on Silicon



- Higher bandgap
  - Higher voltage
- Cheaper substrate material

# Triple-Junction Solar Cells

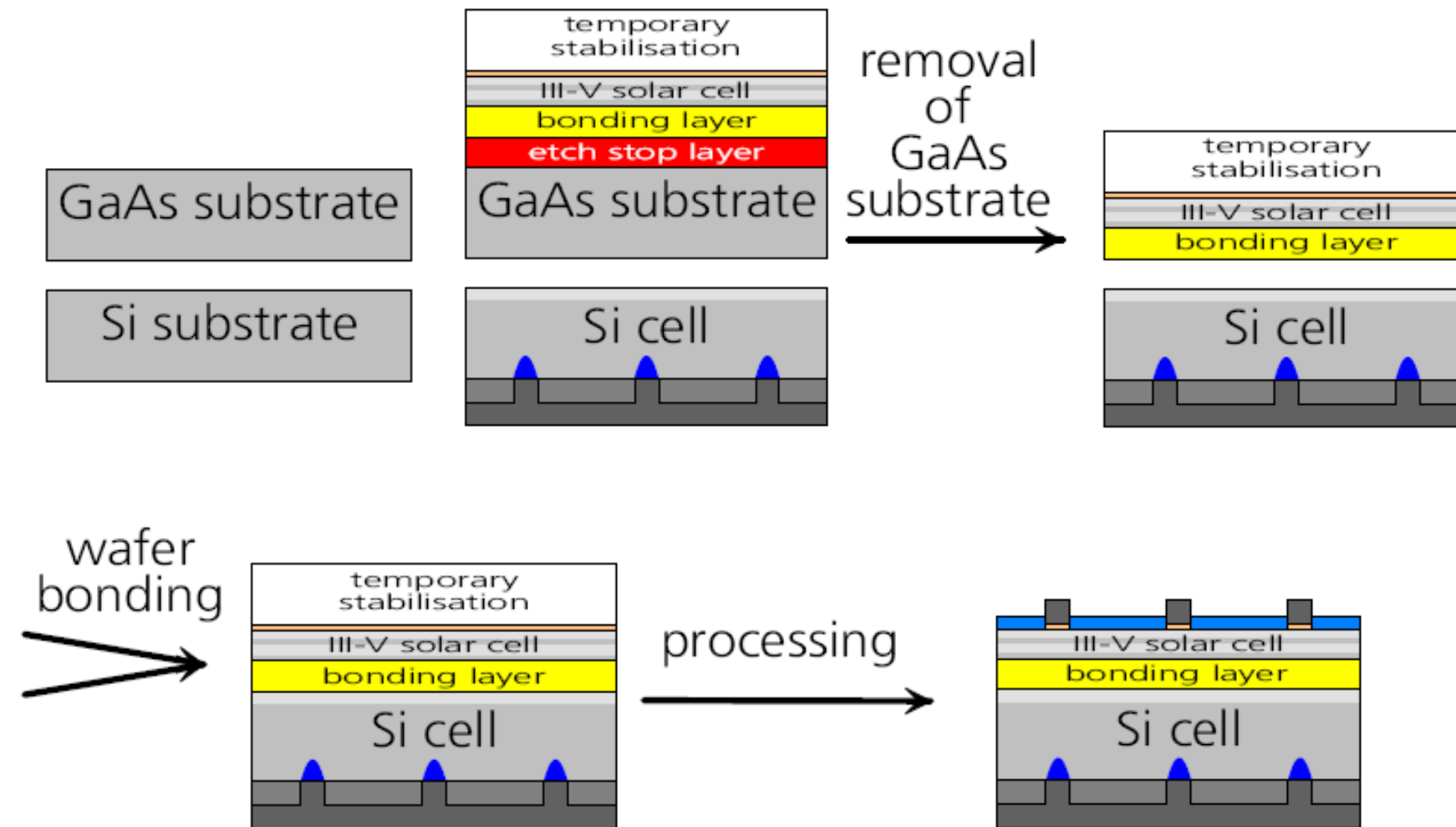
## III-V on Silicon



4% lattice mismatch between III-V dual-junction and silicon solar cell

# III-V on Silicon

## Process of Fabrication

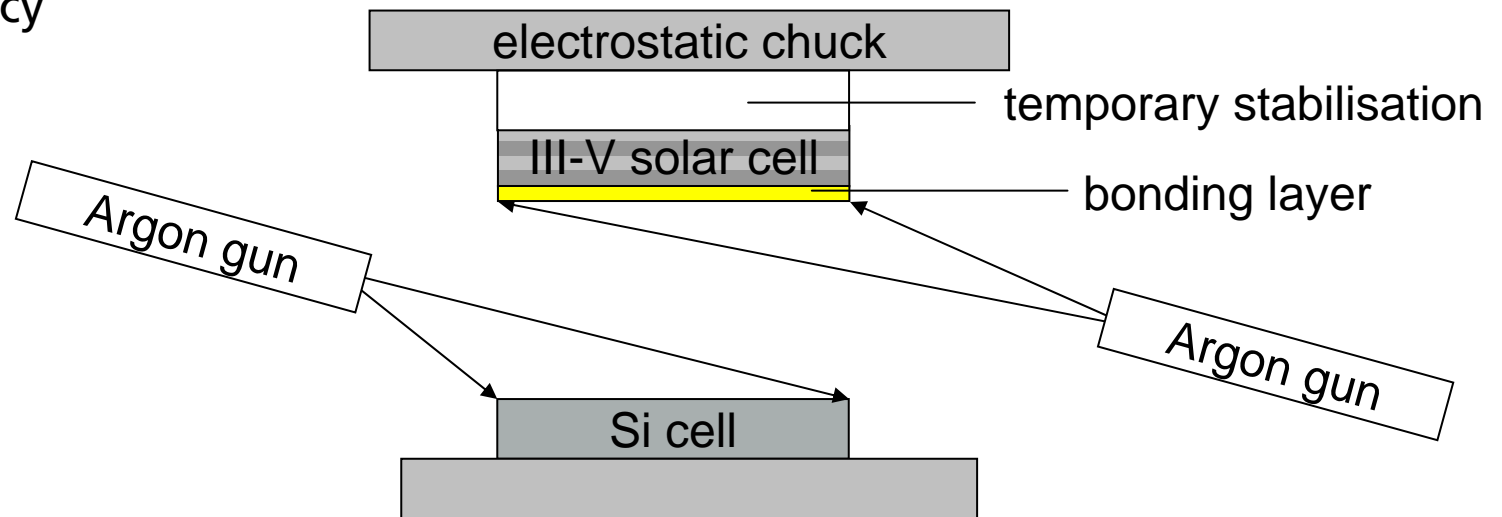


## III-V on Silicon

### Direct Wafer Bonding: Surface Cleaning and Activation

Demands on bond interface:

- High electrical conductivity
- Transparency

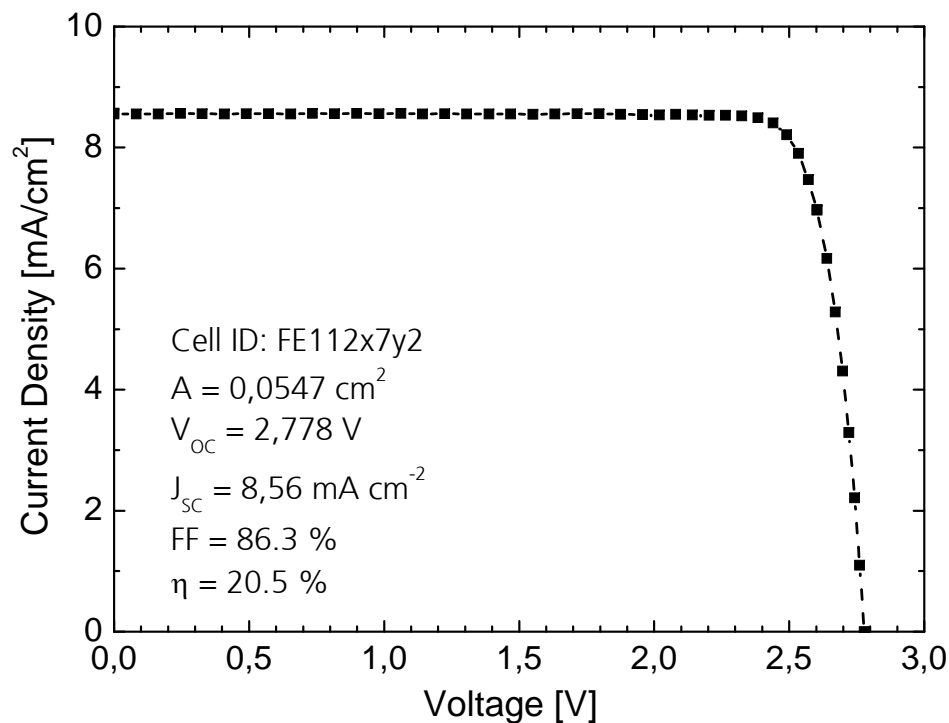


- Surface cleaning and activation by Ar-beam
- Bonding in vacuum chamber at room temperature



# GaInP/GaAs/Si Solar Cell

## IV-Characteristic

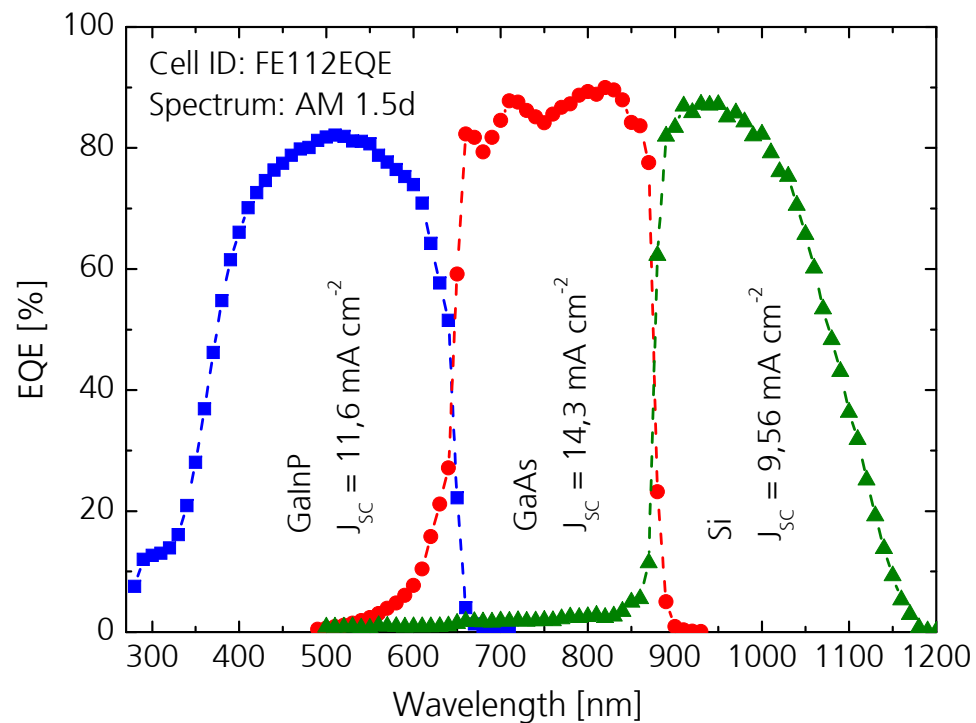


Remarkable cell efficiency for the first GaInP/GaAs/Si solar cell fabricated by wafer bonding:

20.5 % under AM 1.5d spectrum

# GaInP/GaAs/Si Solar Cell

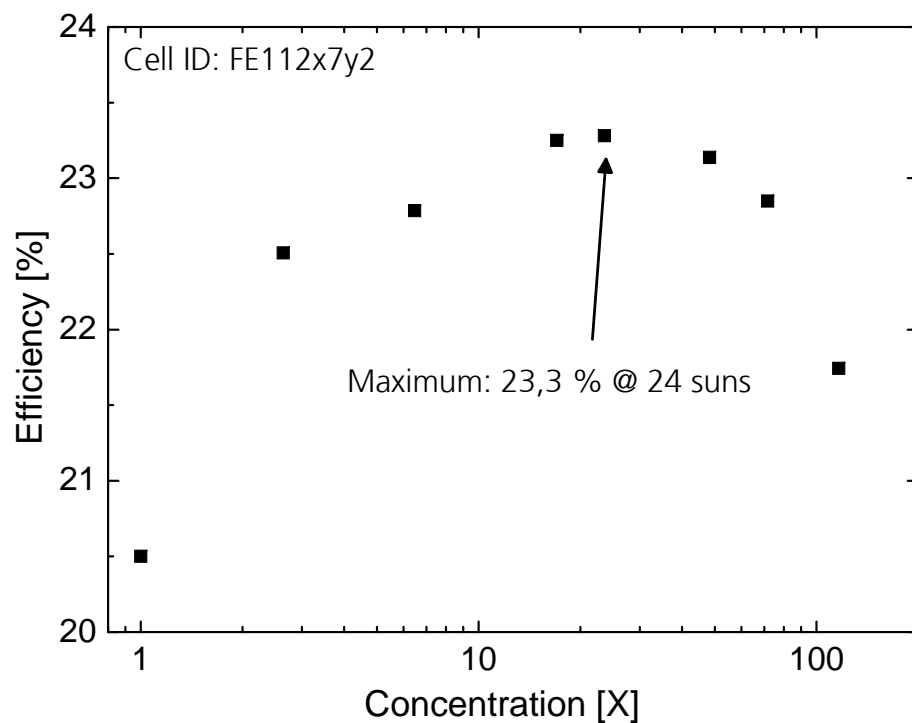
## External Quantum Efficiency



- Si subcell has lowest current density  
→ limits the total current density
- Energy conversion in Si has to be increased
- Thickness of upper subcells should be reduced

# GalnP/GaAs/Si Solar Cell

## Efficiency under Concentrated Illumination

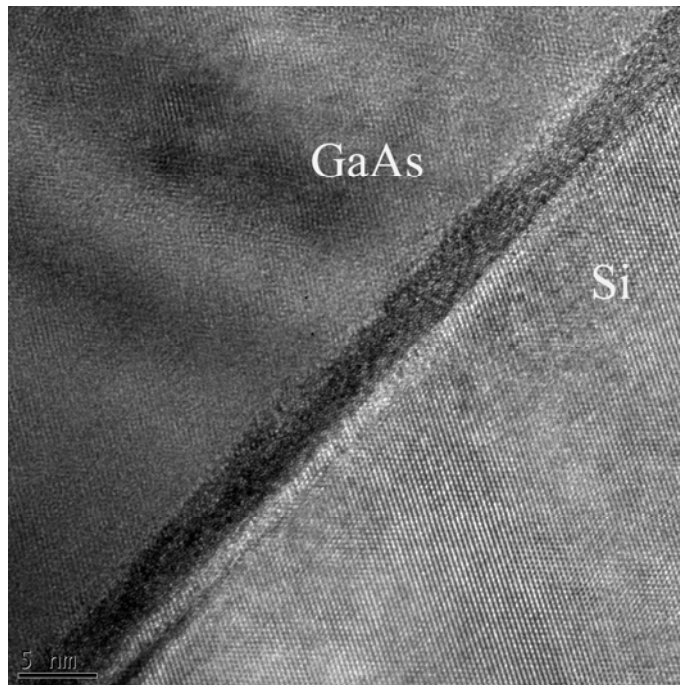


Efficiency starts decreasing  
at 24 suns

→ Series resistance  
in cell structure

# GaInP/GaAs/Si Solar Cell

## TEM Analysis of Bond Interface



High Resolution TEM Image,  
Bright Field, Zone Axis Si

Universität Kiel, Institut für Materialwissenschaft, Gruppe Prof. Dr. Jäger, 2010

- TEM: amorphous layer between GaAs and Si of 3-4 nm thickness
  - Reason for series resistance?

# Summary

- Successful fabrication of first GaInP/GaAs/Si by wafer bonding
- Remarkable cell efficiency of 23.3 % at 24 suns
- Si subcell limits the current density
- Efficiency decreases strongly under high concentration
- Amorphous layer at the bond interface probably reduces current density under high concentration

# Acknowledgements

## I thank...

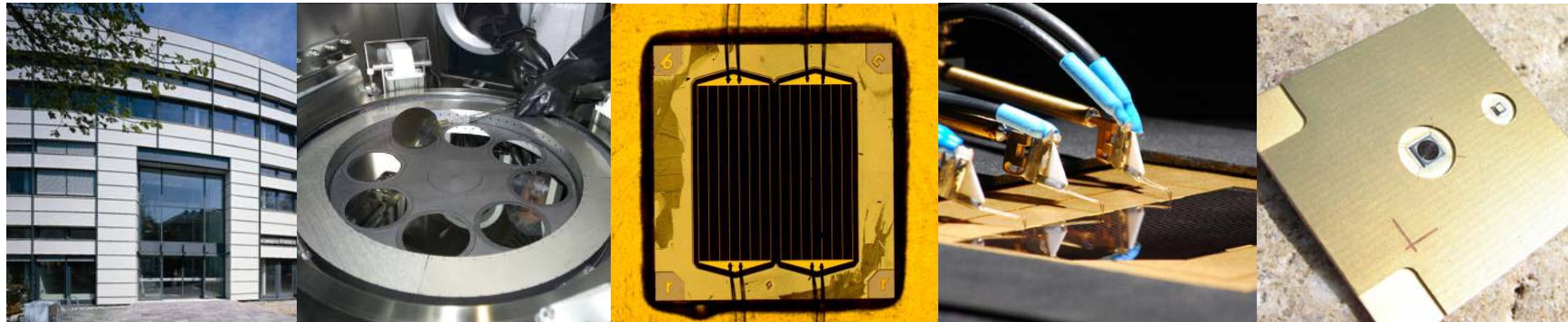


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...all co-workers from the group III-V – Epitaxy and Solar Cells

# Thank You Very Much for Your Attention!



## Fraunhofer Institute for Solar Energy Systems ISE “III-V – Epitaxy and Solar Cells”

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# III-V on Si

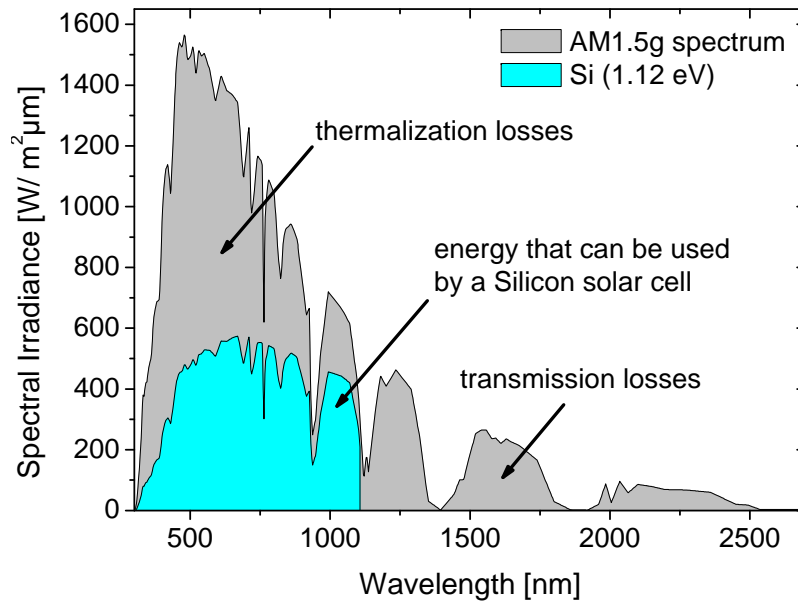
## Process of Production: Lift-Off



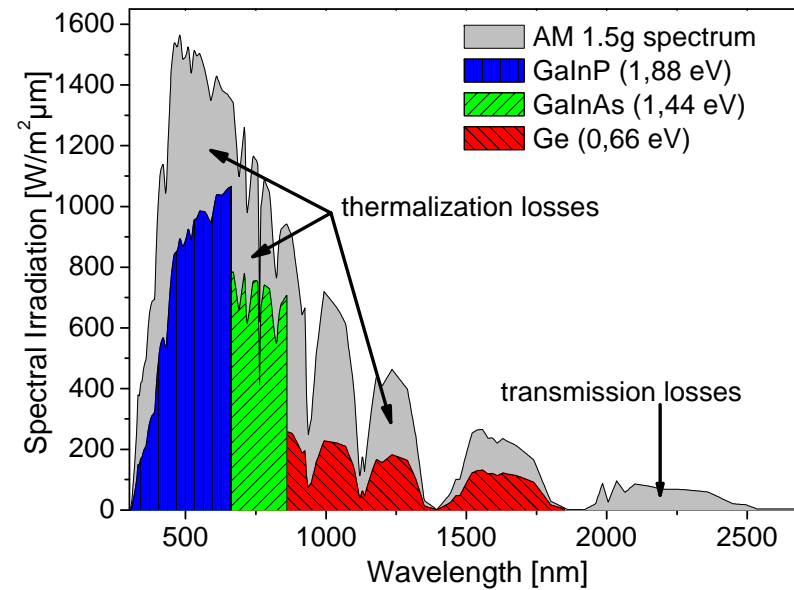


# Triple-Junction Solar Cells

## Theoretical Conversion Efficiency



$$\eta_{\text{theoretical, AM 1.5g}} = 33,3 \%$$



$$\eta_{\text{theoretical, AM 1.5g}} = 50 \%$$